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PTO/SB/08A	ATTY, DOCKET NO. JEV/KAR:1016.2019	SERIAL NO. 10/67854 (Cont. of 10/034068)
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT OUT 1 3 700 H	APPLICANT Randy J. Schwindt et al.	
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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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FOREIGN PATENT DOCUMENTS

							TRANSLATION	
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
EPK.	AY	201205	12/1986	Europe				
EM.	AZ	1-209380	8/23/1989	Japan				
EDK.	BA	2-220453	9/1990	Japan				

PTO/SB/08A	ATTY. DOCKET NO. JEV/KAR: 1016.2019 SERIAL NO. JEV/KAR: 1016.2019 SERIAL NO. JEV/KAR: 1016.2019			
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	APPLICANT Randy J. Schwindt et al.			
(Use several sheets if necessary)	FILING DATE Herewith 10/02/03	GROUP 2829		

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

		OTTER ACT (Including Fullor), Tale, Pale, Falliner, Lagor, Pale,
SA	ВВ	Micromanipulator Company, Inc., "Test Station Accessories." (1983) (mail, unavailable
87K	вс	Micromanipulator Company, Inc., "Model 8000 Test Station." (1986) (marth warailable)
CAL	BD	"Model TPO3000 Series Thermochuck® Systems," four-page product note, Temptronic Corporation, Newton, MA (May 1992 or earlier)
(1,2)	BE	
SIK	BF	"Application Note 1 Controlled Environment Enclosure," two-page application note, Temptronic Corporation, Newton, MA (May 1992 or earlier)
EDK	BG	Micromanipulator Company, Inc. "Model 8000 Test Station." (1988) (marly unavailable
5.78	вн	Applebay, Harry F. Deposition transcript (pp. 61-67) with exhibits 581 A.B.C. describing Flexion AP-1 probe station sold in 1987 (May 1988)
ETK	ВІ	"Cross Section Signatone S-1240," one-page sketch prepared by Signatone counsel. Feb. 1988
E.M.	BJ	"S-1240," two-page product note, Signatone, San Jose, CA (February 1988 or earlier per Signatone counsel)
E.P.K.	BK	Y. Yamamoto, "A Compact Self-Shielding Prober" IEEE Trans., Inst. and Meas., Vol. 38, pp. 1088-1093, (1989)
EZK.	BL	Temptronic's "Guarded" Chuck, one-page note describing guarding system of Temptronic Corporation of Newton, MA, dated 11/15/89.
EDIK	ВМ	Beck & Tomann, "Chip Tester," IBM Technical Disclosure Bulletin, p. 4819 (January 1985).
E.TK	BN	Article by William Knauer entitled "Fixturing for Low-Current/Low Voltage Parametric Testing," appearing in Evaluation Engineering, (1990), pp. 150-153
E.A.K.	во	Hewlett-Packard, "Application Note 356-HP 4142B Modular DC Source/Monitor Practical Application," (Nov. 1987), pp. 1-4
£74.	BP	Hewlett-Packard, H-P Model 4284A Precision LCR Meter, Operation Manual (December 1991) pp. 1-2, 6-9 and 6-15
EXAMINE	er É	DATE CONSIDERED 1/09/05
EXAMINER	: Initial i	f reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in

conformance and not considered. Include copy of this form with next communication to applicant.

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